

Day : Wednesday

Date: 9/28/2005

Time: 16:04:56

PALM INTRANET

Inventor Name Search Result

Your Search was:

Last Name = KUNKEL

First Name = GERHARD

Application#	Patent#	Status	Date Filed	Title	Inventor Name
09161861	6136660	150	09/28/1998	STACKED CAPACITATOR MEMORY CELL AND METHOD OF FABRICATION	KUNKEL, GERHARD
09163658	Not Issued	161	09/30/1998	DYNAMIC RANDOM ACCESS MEMORY LAYOUT	KUNKEL, GERHARD
09250861	Not Issued	164	02/17/1999	METHOD OF IMPROVING THE ETCH RESISTANCE OF PHOTORESISTS	KUNKEL, GERHARD
09272215	6211544	150	03/18/1999	MEMORY CELL LAYOUT FOR REDUCED INTERACTION BETWEEN STORAGE NODES AND TRANSISTORS	KUNKEL, GERHARD
09277669	6083788	150	03/26/1999	STACKED CAPACITOR MEMORY CELL AND METHOD OF MANUFACUTRE	KUNKEL, GERHARD
09282745	6379869	150	03/31/1999	METHOD OF IMPROVING THE ETCH RESISTANCE OF CHEMICALLY AMPLIFIED PHOTORESISTS BY INTRODUCING SILICON AFTER PATTERNING	KUNKEL, GERHARD
09407437	6118683	150	09/29/1999	DYNAMIC RANDOM ACCESS MEMORY CELL LAYOUT	KUNKEL, GERHARD
09408246	6590657	150	09/29/1999	SEMICONDUCTOR STRUCTURES AND MANUFACTURING METHODS	KUNKEL, GERHARD
09460700	6420272	150	12/14/1999	METHOD FOR REMOVAL OF HARD MASK USED TO DEFINE NOBLE METAL ELECTRODE	KUNKEL, GERHARD
09522883	6365328	150	03/10/2000	SEMICONDUCTOR	KUNKEL,

				STRUCTURE AND MANUFACTURING METHOD	GERHARD
<u>09561469</u>	<u>6511791</u>	150	04/28/2000	MULTIPLE EXPOSURE PROCESS FOR FORMATION OF DENSE RECTANGULAR ARRAYS	KUNKEL, GERHARD
<u>09561472</u>	<u>6451508</u>	150	04/28/2000	PLURAL INTERLEAVED EXPOSURE PROCESS FOR INCREASED FEATURE ASPECT RATIO IN DENSE ARRAYS	KUNKEL, GERHARD
<u>09561581</u>	Not Issued	161	04/28/2000	Group connection of reticle sub- shapes to reduce line shortening and improve pattern fidelity	KUNKEL, GERHARD
<u>09597116</u>	Not Issued	161	06/20/2000	Buried bit line-shallow trench isolation defined active semiconductor areas	KUNKEL, GERHARD
<u>09597123</u>	<u>6727989</u>	150	06/20/2000	ENHANCED OVERLAY MEASUREMENT MARKS FOR OVERLAY ALIGNMENT AND EXPOSURE TOOL CONDITION CONTROL	KUNKEL, GERHARD
<u>09598789</u>	<u>6911687</u>	150	06/21/2000	Buried bit line-field isolation defined active semiconductor areas	KUNKEL, GERHARD
<u>09602717</u>	<u>6383691</u>	150	06/26/2000	Photomask and method for increasing image aspect ratio while relaxing mask fabrication requirements	KUNKEL, GERHARD
<u>09603337</u>	<u>6282116</u>	250	06/26/2000	Dynamic random access memory	KUNKEL, GERHARD
<u>09609472</u>	Not Issued	161	06/30/2000	CONCAVE SHAPED STACK CAPACITOR	KUNKEL, GERHARD
<u>09801413</u>	<u>6558883</u>	150	03/08/2001	APPARATUS AND METHOD FOR PATTERNING A SEMICONDUCTOR WAFER	KUNKEL, GERHARD
<u>09916917</u>	<u>6606151</u>	150	07/27/2001	GRATING PATTERNS AND METHOD FOR DETERMINATION OF AZIMUTHAL AND RADIAL ABERRATION	KUNKEL, GERHARD
<u>09957937</u>	<u>6566219</u>	150	09/21/2001	METHOD OF FORMING A SELF ALIGNED TRENCH IN A SEMICONDUCTOR USING A PATTERNED SACRIFICIAL LAYER FOR DEFINING THE	KUNKEL, GERHARD

				TRENCH OPENING	
10406888	6842222	150	04/04/2003	METHOD OF REDUCING PITCH ON SEMICONDUCTOR WAFER	KUNKEL, GERHARD
10424039	6809800	150	04/25/2003	APPARATUS FOR PATTERNING A SEMICONDUCTOR WAFER	KUNKEL, GERHARD
10487911	Not Issued	30	08/13/2004	Photolithographic mask	KUNKEL, GERHARD
10637193	Not Issued	30	08/08/2003	Method for the characterization of an illumination source in an exposure apparatus	KUNKEL, GERHARD
10787118	Not Issued	30	02/27/2004	Phase-shift mask	KUNKEL, GERHARD
10870699	Not Issued	30	06/17/2004	Method for forming an opening on an alternating phase shift mask	KUNKEL, GERHARD
10965693	Not Issued	30	10/14/2004	Method for producing a mask adapted to an exposure apparatus	KUNKEL, GERHARD
11056402	Not Issued	20	02/14/2005	Method for producing a phase mask	KUNKEL, GERHARD
11065931	Not Issued	20	02/25/2005	Run to run control for lens aberrations	KUNKEL, GERHARD
11066638	Not Issued	20	02/25/2005	System for analyzing images of blazed phase grating samples	KUNKEL, GERHARD
11066913	Not Issued	30	02/25/2005	Optimizing focal plane fitting functions for an image field on a substrate	KUNKEL, GERHARD
11067191	Not Issued	20	02/25/2005	Optimizing light path uniformity in inspection systems	KUNKEL, GERHARD
11170189	Not Issued	20	06/29/2005	Method for adapting structure dimensions during the photolithographic projection of a pattern of structure elements onto a semiconductor wafer	KUNKEL, GERHARD
60234502	Not Issued	159	09/22/2000	Self aligned trench and method of forming the same	KUNKEL, GERHARD

Inventor Search Completed: No Records to Display.

Search Another: Inventor	Last Name	First Name	<input type="button" value="Search"/>
	<input type="text" value="KUNKEL"/>	<input type="text" value="GERHARD"/>	

To go back use Back button on your browser toolbar.

Back to [PALM](#) | [ASSIGNMENT](#) | [OASIS](#) | [Home page](#)